



DEP-REF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

2005 OCT 28 PM 4: 49

Mamoru NAKASUJI et al.

: Mail Stop: ACCOUNTING DIVISION
REFUND BRANCH

Serial No. 10/651,105

Filed August 29, 2003

: Attorney Docket No. 2003_1217A
Confirmation No. 7747

ELECTRON BEAM SYSTEM

REQUEST FOR REFUND

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants request a refund of \$430 charged to Deposit Account No. 23-0975 on February 15, 2005 for a two month extension of time. Applicants assert the charge is incorrect.

The Office Action dated November 2, 2004 established a three month response period. The last date for a timely submission would be February 2, 2005. Applicants' Attorney submitted a Response to Restriction Requirement (copy enclosed) on Monday, January 31, 2005. This was obviously within the timely response period and so, no fee should have been incurred.

Kindly credit the refund of \$430 to the deposit account of undersigned, no. 23-0975. If there are any questions, please contact Kara Reade, Accounting Assistant, at (202) 721-8226.

Respectfully submitted,

Mamoru NAKASUJI et al.

By

Joseph M. Gorski
Registration No. 46,500
Attorney for Applicants

JMG/ker
WENDEROTH, LIND & PONACK, L.L.P.
2033 K Street, N.W., Suite 800
Washington, D.C. 20006-1021
Facsimile (202) 721-8250
October 27, 2005

2003_1217A

BEST AVAILABLE COPY



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 2005 OCT 28 PM 4:49

In re application of : Confirmation No. 7747
Mamoru NAKASUJI et al. : Docket No. 2003-1217A
Serial No. 10/651,105 : Group Art Unit 2881
Filed August 29, 2003 : Examiner James P. Leybourne
ELECTRON BEAM SYSTEM :

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

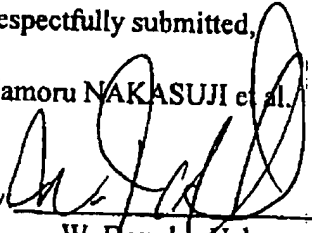
In response to the Restriction Requirement of November 2, 2004, Applicants hereby elect the invention of Group I, claims 1-26 and 54-62, drawn to a projection type transmission microscope, without traverse, for further prosecution.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Mamoru NAKASUJI et al.

By


W. Douglas Hahn
Registration No. 44,142
Attorney for Applicants

WDH/gtg
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
January 31, 2005

BEST AVAILABLE COPY



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Free Only

In re application of : Confirmation No. 7747
Mamoru NAKASUJI et al. : Docket No. 2003-1217A
Serial No. 10/651,105 : Group Art Unit 2881
Filed August 29, 2003 : Examiner James P. Leybourne
ELECTRON BEAM SYSTEM :

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

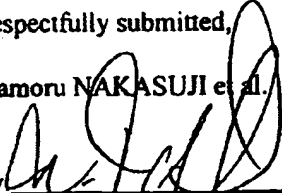
In response to the Restriction Requirement of November 2, 2004, Applicants hereby elect the invention of Group I, claims 1-26 and 54-62, drawn to a projection type transmission microscope, without traverse, for further prosecution.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Mamoru NAKASUJI et al.

By


W. Douglas Hahn
Registration No. 44,142
Attorney for Applicants

02/15/2005 CHODRE 00000002 230975 10651105
01 FC:1252 430.00 CR

WDH/gtg
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
January 31, 2005

Adjustment Date: 12/06/2005 SDIRETA1
02/15/2005 CHODRE 00000002 230975 10651105
01 FC:1252 430.00 CR

BEST AVAILABLE COPY